

		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. MI22-1035		SERIAL NO. 09/234,233	
LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)				APPLICANT Weimin Li			
				FILING DATE January 20, 1999		GROUP 2818	
U.S. PATENT DOCUMENTS							
*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
DV	AA	5,498,555	03/96	Lin			
DV	AB	6,153,504	11-00	Shields et al.			
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						
	AL						
FOREIGN PATENT DOCUMENTS							
		Document Number	Date	Country	Class	Subclass	Translation
							Yes No
DV	AM	7201716	08/95	Japan			x
DV	AN	8046186	02/96	Japan			x
DV	AO	10-163083	06/98	Japan			
OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, Etc.)							
DV	AP		Wolf, S., Silicon Process., Vol 2 48-49 and 435				
	AO						
	AR						
EXAMINER <i>Shuland</i>				DATE CONSIDERED 06/17/04			
*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							

EL 979954377